


<b>Search Notes</b>  	<b>Application/Control No.</b>  10771874	<b>Applicant(s)/Patent Under Reexamination</b>  HAJI, GOUDARZ
	<b>Examiner</b>  Christopher S Kim	<b>Art Unit</b>  3752

SEARCHED			
Class	Subclass	Date	Examiner
239	88-96, 570, 571		
137	513.3	3/25/08	CK

SEARCH NOTES		
Search Notes	Date	Examiner
137/ J. Rivell	3/25/08	CK

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner